

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: To be assigned
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Applicants: Yoshifumi Okabe et al.
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Title: Semiconductor Device And Method Of Manufacturing
Same
Attorney Docket: 4041J-000499/DVE

Director of The United States Patent and Trademark Office
P.O. Box 1450
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PRELIMINARY AMENDMENT

Sir:

Prior to examination of the present application, please consider the following.

Amendments to the Specification being on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 5 of this paper.